



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

September 2, 2009

Applicants: Takaomi NAKAYAMA et al
For: TREATING SOLUTION FOR SURFACE TREATMENT OF METAL AND
A METHOD FOR SURFACE TREATMENT

Serial No.: 10/537 329 Group: 1793
Confirmation No.: 8404
Filed: December 2, 2005 Examiner: Zheng
International Application No.: PCT/JP2003/015868
International Filing Date: December 11, 2003
Atty. Docket No.: 4626.P0002US

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

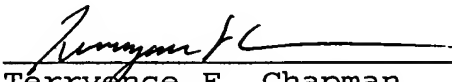
RESPONSE

Sir:
In response to the Office Action dated June 4, 2009,
please amend the above-identified application as follows:
(Please see following pages.)

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service with
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Terryence F. Chapman